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**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re the Application of: **Hiroshi MORIOKA**

Art Unit: **1795**

Application Number: **10/692,722**

Examiner: **Daborah Chacko-Davis**

Filed: **October 27, 2003**

Confirmation Number: **9699**

For: **MICRO PATTERN FORMING METHOD AND SEMICONDUCTOR DEVICE  
MANUFACTURING METHOD**

Attorney Docket Number: **032045**

Customer Number: **38834**

**AMENDMENT UNDER 37 C.F.R. § 1.111**

**MAIL STOP: Amendment**

Commissioner for Patents

P. O. Box 1450

Alexandria, VA 22313-1450

June 24, 2009

Sir:

This paper is filed in response to the Office Action dated April 16, 2009.

Amendments to the Claims begin on page 2 of this paper.

Remarks/Arguments begin on page 9 of this paper.